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Docket No.: 60188-782 PATENT

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toyoji ITOU

Serial No.: : Group Art Unit:

Filed: February 26, 2004 : Examiner:

For: METHOD FOR FABRICATION SEMICONDUCTOR DEVICE

### **PRELIMINARY AMENDMENT**

Mail Stop Preliminary Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: